## CLAIM AMENDMENTS

- 1. (Original) A process for preparing a layer of a nano-porous metal oxide semiconductor comprising the steps of: (i) providing metal oxide semiconductor nano-particles prepared by a wet precipitation process, (ii) heating said nano-particles at a temperature in the range of 250 to 600°C, (iii) preparing a dispersion of said heat-treated nano-particles from step (ii), (iv) applying said dispersion prepared in step (iii) to a support to produce a coating; and (v) subjecting said coating to a pressure in the range of 100 to 1000 bar at a temperature below 250°C.
- 2. (Original) Process according to claim 1, wherein said metal oxide is selected from the group consisting of titanium oxides, tin oxides, niobium oxides, tantalum oxides, tungsten oxides and zinc oxides.
- 3. (Original) Process according to claim 1, wherein said pretreatment temperature is in the range of 300 to 500°C.
- 4. (Original) Process according to claim 1, wherein said sintering pressure is in the range 400 to 600 bar.
- 5. (Original) Process according to claim 1, wherein the process further comprises heating said coating subjected to pressure from step (v) at a temperature of 100 to 200°C.
- 6. (Original) Process according to claim 1, wherein said nano-porous metal oxide semiconductor has a band-gap of greater than 2.9 eV.
- 7. (Original) Process according to claim 1, wherein said nano-porous metal oxide nano-particles have a mean number averaged particle size  $\leq 20$  nm.
- 8. (Original) A layer of a nano-porous metal oxide semiconductor obtained by a process for preparing a layer of a nano-porous metal oxide semiconductor comprising the steps of: (i) providing metal oxide semiconductor nano-particles prepared by a wet precipitation process, (ii) heating said nano-particles at a temperature in the range of 250 to 600°C, (iii) preparing a dispersion of said heat-treated nano-particles from step (ii), (iv) applying said dispersion prepared in step (iii) to a support to produce a coating; and (v)

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subjecting said coating to a pressure in the range of 100 to 1000 bar at a temperature between 20 and 250°C.

- 9. (Original) Layer according to claim 8, wherein said layer contains at least one spectral sensitizer for the nano-porous metal oxide semiconductor selected from the group consisting of metal chalcogenide nano-particles with a band-gap between 1.5 and 2.9 eV, organic dyes, and metallo-organic dyes.
- 10. (Original) A photovoltaic device comprising a layer of a nano-porous metal oxide semiconductor obtained by a process for preparing a layer of a nano-porous metal oxide semiconductor comprising the steps of: (i) providing metal oxide semiconductor nano-particles prepared by a wet precipitation process, (ii) heating said nano-particles at a temperature in the range of 250 to 600°C, (iii) preparing a dispersion of said heat-treated nano-particles from step (ii), (iv) applying said dispersion prepared in step (iii) to a support to produce a coating; and (v) subjecting said coating to a pressure in the range of 100 to 1000 bar at a temperature below 250°C.